Special Topics on Basic EECS I VLSI Devices Lecture 22

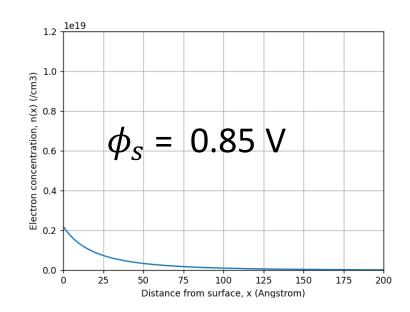
Sung-Min Hong (smhong@gist.ac.kr)
Semiconductor Device Simulation Laboratory
School of Electrical Engineering and Computer Science
Gwangju Institute of Science and Technology

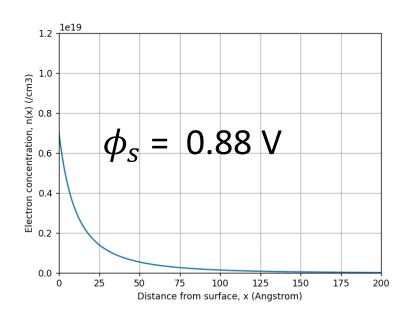
Strong inversion

Beyond strong inversion,

$$\frac{d\phi}{dx} \approx -\sqrt{\frac{2k_BTN_a}{\epsilon_{si}} \left(\frac{q\phi}{k_BT} + \frac{n_i^2}{N_a^2} \exp\left(\frac{q\phi}{k_BT}\right)\right)}$$
 Taur, Eq. (2.191)

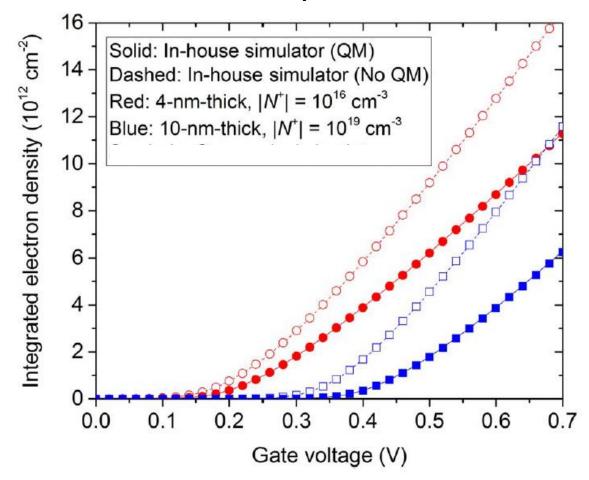
-The electrons are distributed extremely close to the surface with an inversion-layer width less than 50 Å.





Strong inversion

- Quantum confinement effect
 - -A peak distribution 10~20 Å away from the surface



MOS equation

- Up to now, $Q_{\mathcal{S}}(\phi_{\mathcal{S}})$ is found. We can control only V_g .
 - Relation between V_g and ϕ_s

$$V_g - V_{fb} = V_{ox} + \phi_s = -\frac{Q_s}{C_{ox}} + \phi_s$$
 Taur, Eq. (2.195)

 $\frac{\epsilon_{ox}}{t_{ox}}$, oxide capacitance per unit area

– In general, $Q_s(\phi_s)$ is known. We can solve the above equation.

Taur, Eq. (2.182)

Homework#5

- Draw ϕ_S as a function of V_g (> 0 V).
 - -Assume that N_a = 10¹⁷ cm⁻³, t_{ox} = 10 nm, and V_{fb} = -0.88 V.
 - Hint: Calculate V_g using ϕ_s by using Taur, Eq. (2.195).

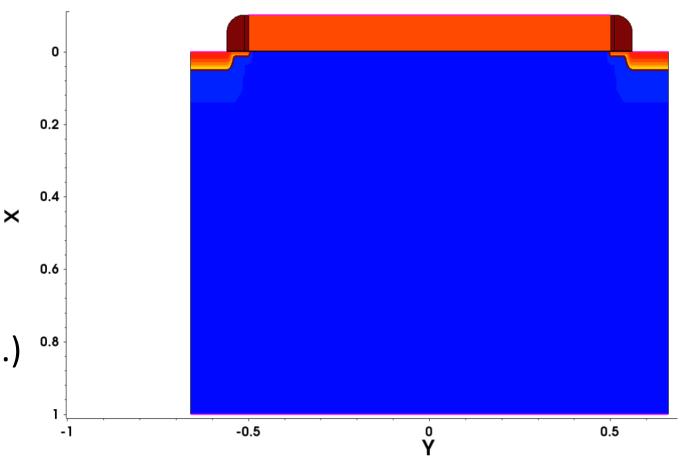
TCAD simulation of a long-channel MOSFET

• Channel length, 1 μm

$$-V_{fb}$$
 is -1.08 V.

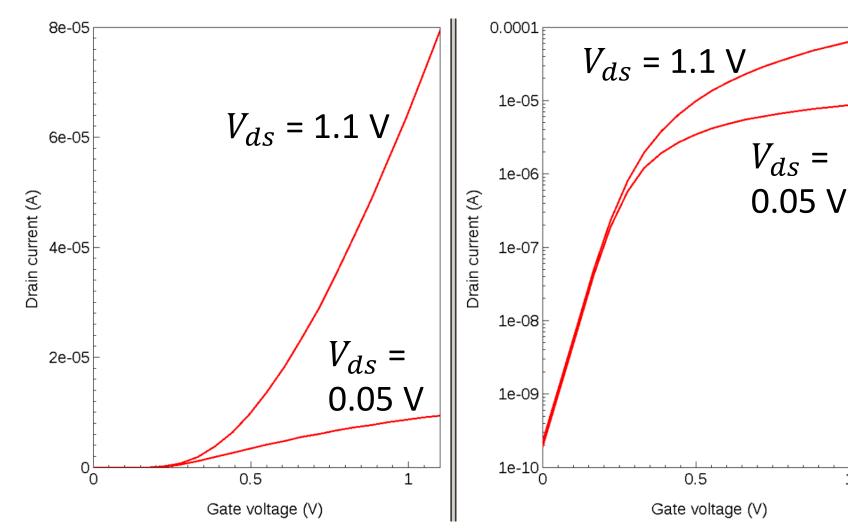
- $-t_{ox}$ is 1.2 nm.
- $-C_{ox}$ is 2.88X10⁻⁶ F/cm².
- $-V_{DD}$ of 1.1 V

- (Estimate its technology node.)



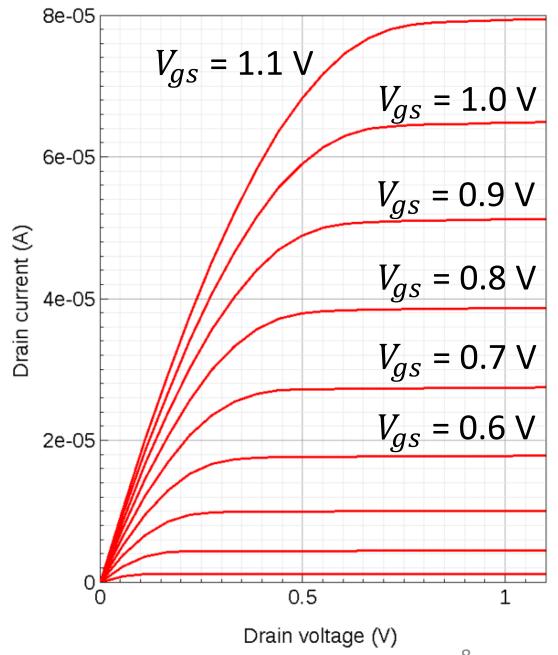
I_d versus V_{gs}

Input characteristics



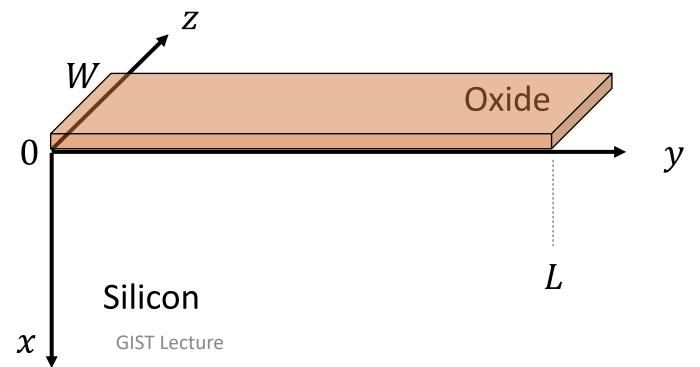
I_d versus V_{ds}

- Output characteristics
 - -Triode mode
 - Saturation mode



Schematic

- x = 0 at silicon surface
 - -y = 0 at the source and y = L at the drain
 - Source and substrate are grounded.
 - Uniform p-type substrate



Gradual channel approximation

• Variation of the electric field in the y-direction is much less than the corresponding variation in the x-direction.

$$\left| \frac{\partial^2 \phi}{\partial x^2} \right| \gg \left| \frac{\partial^2 \phi}{\partial y^2} \right|$$

- Poisson equation

$$\frac{\partial^2 \phi}{\partial x^2} + \frac{\partial^2 \phi}{\partial y^2} = -\frac{q}{\epsilon_{si}} [p(x, y) - n(x, y) - N_a]$$

- Poisson equation under the GCA

$$\frac{d^2\phi}{dx^2} = -\frac{q}{\epsilon_{si}} [p(x,y) - n(x,y) - N_a]$$
 Taur, Eq. (2.175)

Electron quasi-Fermi potential, V(y) as ϕ_n in Taur,

It was written Eq. (2.61).

- It is assumed that V is independent of x.
 - Why? MOSFET current flows predominantly along the y-direction.
 - -Since $\mathbf{J}_n = -q\mu_n n \nabla \phi_n$, V varies mainly along the y-direction.
 - Boundary conditions:

$$V(y = 0) = V_S = 0$$

 $V(y = L) = V_d = V_{dS}$

• Electron density, n(x, y)

$$n(x,y) = \frac{n_i^2}{N_a} \exp\left(\frac{q}{k_B T}(\phi - V)\right)$$

Taur, Eq. (3.1)

Still, ϕ_R is the reference value.

Our previous expressions (1)

- They are modified by V. (Terms related with the electron density)
 - Electric field

$$\begin{split} E_{x}^{2}(x,y) &= \left(\frac{d\phi}{dx}\right)^{2} \\ &= \frac{2k_{B}TN_{a}}{\epsilon_{Si}} \left[\left(\exp\left(-\frac{q\phi}{k_{B}T}\right) + \frac{q\phi}{k_{B}T} - 1 \right) \right. \\ &\left. + \frac{n_{i}^{2}}{N_{a}^{2}} \left(\exp\left(-\frac{qV}{k_{B}T}\right) \left(\exp\left(\frac{q\phi}{k_{B}T}\right) - 1 \right) - \frac{q\phi}{k_{B}T} \right) \right] \text{ Taur, Eq. (3.2)} \end{split}$$

Our previous expressions (2)

- They are modified by V. (Terms related with the electron density)
 - Surface inversion

$$\phi(0,y) = V(y) + 2\phi_B$$
 Taur, Eq. (3.3)

Maximum depletion layer width

$$W_{dm} = \sqrt{\frac{2\epsilon_{si}[V(y) + 2\phi_B]}{qN_a}}$$
 Taur, Eq. (3.4)

• Summary: With the GCA, our MOS expressions are re-used only with modification by V.

Drain current

• Electron current density at a point
$$(x, y)$$

$$J_n(x, y) = -q\mu_n n(x, y) \frac{dV}{dy}$$

Taur, Eq. (3.5)

- (It includes both the drift and diffusion currents.)
- When integrated from x = 0 to x_i ,

$$I_d(y) = qW \int_0^{x_i} \mu_n n(x, y) \frac{dV}{dy} dx$$

Sign change due to convention of terminal current

z-directional width

Taur, Eq. (3.6)

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Further simplification

• Electron current density at a point
$$(x, y)$$

$$I_d(y) = qW \int_0^{x_i} \mu_n n(x, y) \frac{dV}{dy} dx = -\mu_{eff} W \frac{dV}{dy} \left(-q \int_0^{x_i} n(x, y) dx \right)$$

$$= -\mu_{eff} W \frac{dV}{dy} Q_i(y)$$
Taur, Eq. (3.8)

- We introduce an effective mobility, μ_{eff} .
- Since V is a function of y only, V is interchangeable with y.

$$Q_i(y) = Q_i(V)$$

-Then,

$$I_d(y)dy = \mu_{eff}W[-Q_i(V)]dV$$

$I_d(y)$ is actually a constant.

• When integrated from y=0 to L, (from V=0 to V_{ds})

$$I_d = \mu_{eff} \frac{W}{L} \int_0^{V_{ds}} [-Q_i(V)] dV$$
 Taur, Eq. (3.10)

-Then, how can we find $Q_i(V)$? (We must perform the x-directional integration.)

$$Q_{i} = -q \int_{0}^{x_{i}} n(x, y) dx = -q \int_{\phi_{s}}^{\delta} n(\phi, V) \frac{dx}{d\phi} d\phi$$

$$= -q \int_{\delta}^{\phi_{s}} \frac{\left(n_{i}^{2}/N_{a}\right) \exp\left(\frac{q}{k_{B}T}(\phi - V)\right)}{E_{x}(\phi, V)} d\phi$$

Taur, Eq. (3.12)

Then, how can we determine ϕ_{c} ?

• For given
$$V_{gs}$$
 and V , we can solve the MOS equation.
$$V_{gs} = V_{fb} + \phi_s - \frac{Q_s}{C_{ox}}$$

$$= V_{fb} + \phi_s + \frac{\sqrt{2\epsilon_{si}k_BTN_a}}{C_{ox}} \left[\frac{q\phi_s}{k_BT} + \frac{n_i^2}{N_a^2} \exp\left(\frac{q}{k_BT}(\phi_s - V)\right) \right]^{1/2}$$

Taur, Eq. (3.14)

– We can numerically solve the above equation to obtain ϕ_s .

Pao-Sah double integral

• Finally, the expression for I_d reads

$$I_{d} = q\mu_{eff} \frac{W}{L} \int_{0}^{V_{ds}} \left[\int_{\delta}^{\phi_{s}} \frac{\left(n_{i}^{2}/N_{a}\right) \exp\left(\frac{q}{k_{B}T}(\phi - V)\right)}{E_{x}(\phi, V)} d\phi \right] dV$$

Taur, Eq. (3.13)

- It is the Pao-Sah double integral.
- Rigorous within the GCA, but it is difficult to evaluate.

Thank you!